

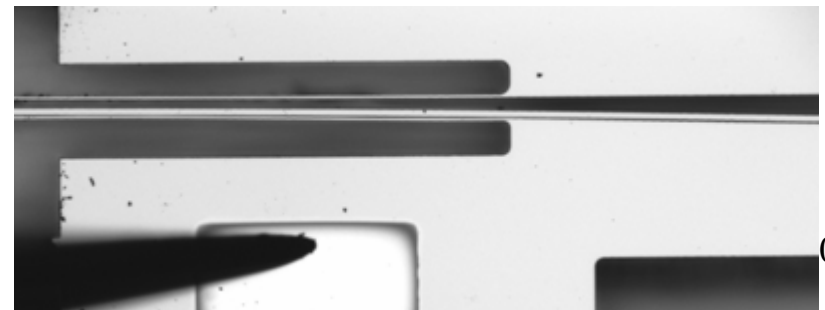
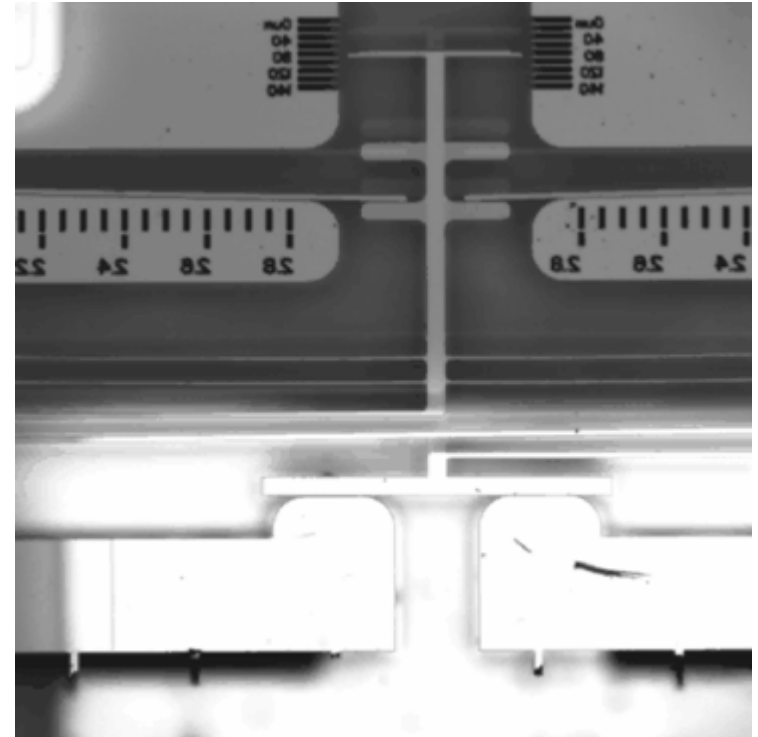
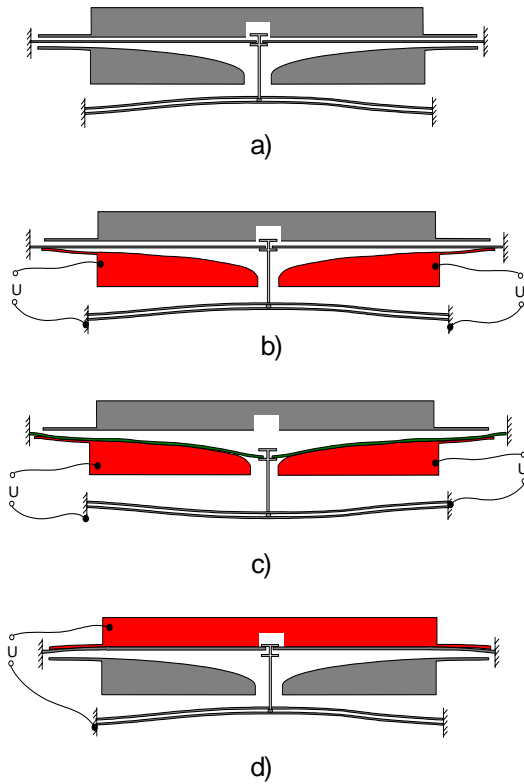
# Alex Slocum's MEMS Research

- Relays
  - Bistable structures actuated with starting-zone electrostatic zippers
- Assembly
  - Kinematic and elastic averaging structures
- Nanogate
  - High precision flow control
  - RF filter
  - Molecule sorter
- XY flexure
  - X and Y axes fully decoupled

# Electrostatic Zipper Actuators

## Jian Li's Ph.D. thesis

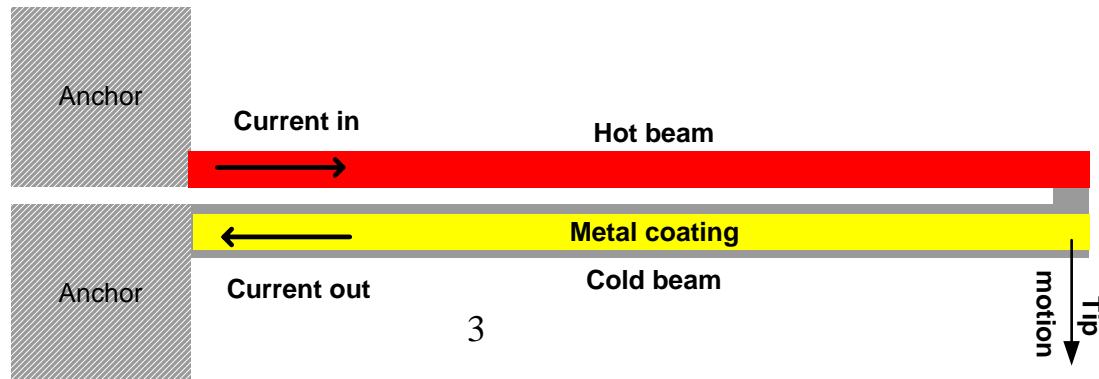
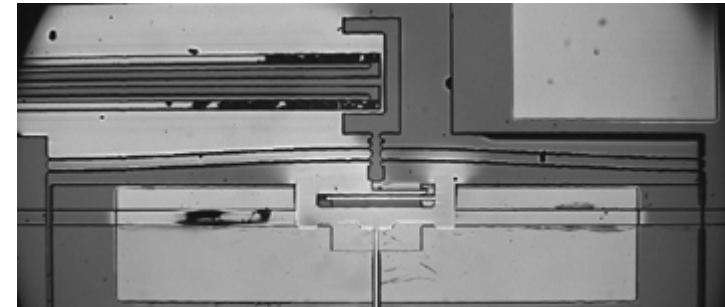
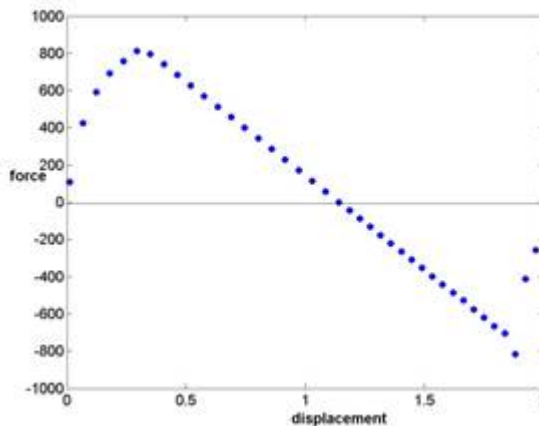
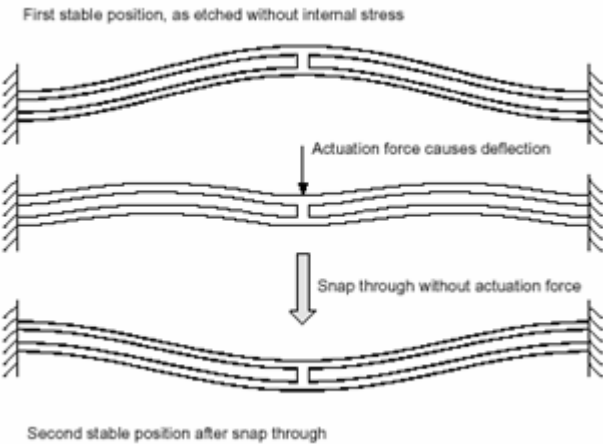
- The fundamental new elements are the compliant starting zones (**inflexible** made *flexible*)



# Bistable Relay Elements

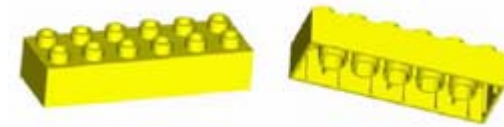
## Jin Qiu's Ph.D. thesis

- A through-wafer etched bistable double-beam can be bistable without any initial preload
  - Two beams are coupled at the middle, thus quenching the 2<sup>nd</sup> mode which is unstable
- Prof. Michael Brenner (formally of MIT) developed the optimization algorithm to give 1:1 force ratio (actuate/contact force)

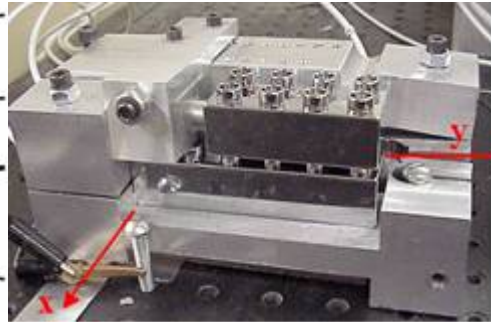
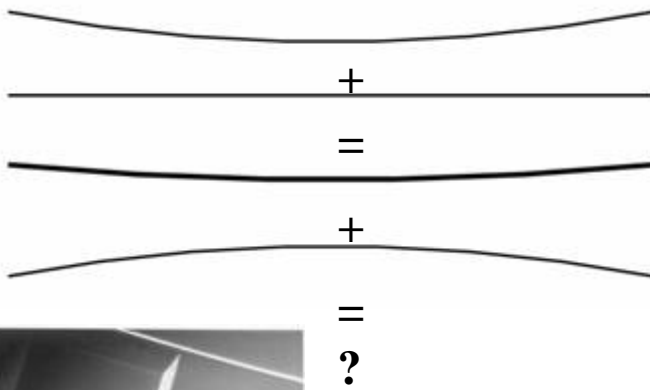
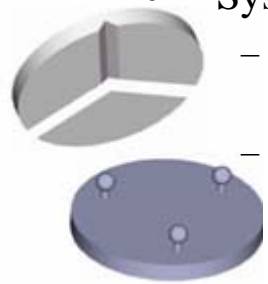


# Exact Constraint Design: Wafer Alignment

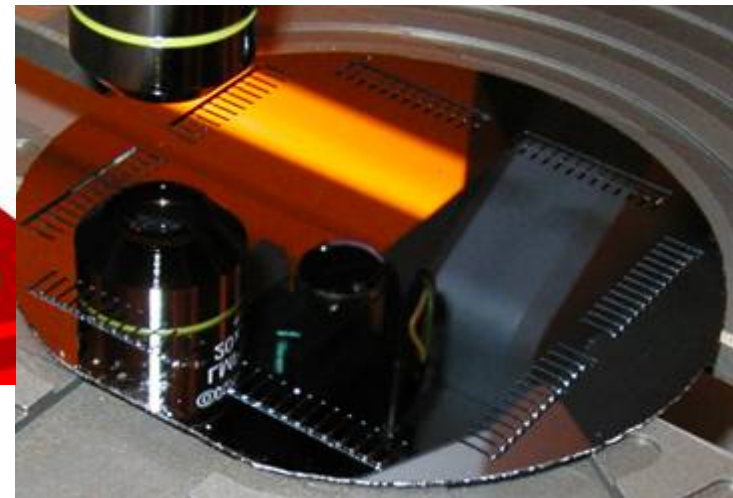
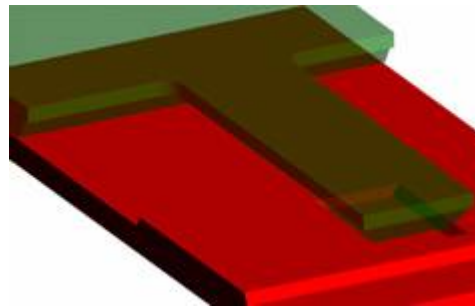
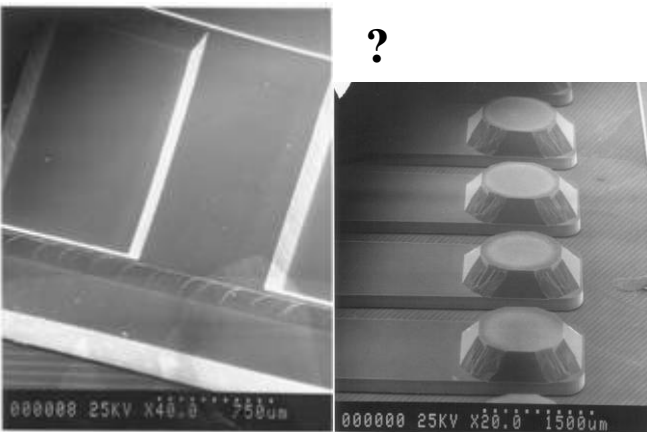
## Alexis Weber's S.M. Thesis



- Systems such as micro engines are formed from a stack of bonded wafers
  - The stack must be bonded one wafer at a time, because each added wafer must be optically positioned with respect to the stack
  - Problems can occur if a concave wafer (R) is bonded to a flat wafer, and the resulting concave wafer (R/2) is then to be bonded to a convex wafer (-R)
    - As the stack thickness, wafers may crack when forced to an opposite signed curvature surface
- It would be desirable to be able to align all the wafers simultaneously, and then press them together for bonding
- Design kinematic/elastic averaging features into wafers:



	X [ $\mu\text{m}$ ]	Y [ $\mu\text{m}$ ]	Error [ $\mu\text{m}$ ]
<b>Average Accuracy</b>	0.88	-1.08	1.41
<b>Repeatability</b>	0.63	1.06	1.06



# Nanogate Research Area

Dr. James White's Post-Doc

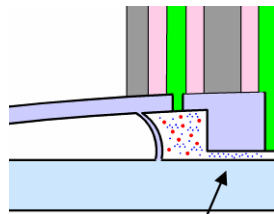
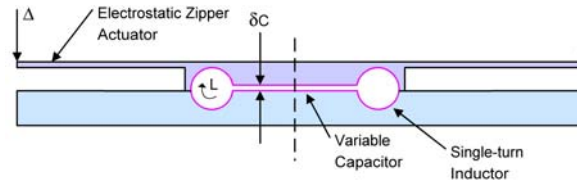
Hong Ma's Ph.D. research

Electro-Mechanically Tunable  
RF LC Tank

“Frequency Agile”  
communications, (100M world  
phones by 2006)

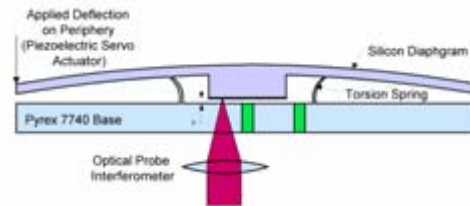
Secure networks, electronic  
surveillance.

Sensor networks, unstructured  
(short-range) communication  
systems.



Fluorescent  
Microspheres

Mechanically Controllable Separations  
Liquid Phase  
market  
Scientific Instruments



**Core Technology**



Ultra-High Precision Valve  
“Small Gap Chromatography”  
markets  
Miniaturized Gas Sensor  
Gas Flow Servo Valve

MEMS Surface  
Force Apparatus  
Angstrom-Level Gap  
Control  
Force /  
Displacement  
market  
Scientific  
Instruments

# 2 DOF X-Y Flexure Stages

Shorya Awtar's Ph.D. Thesis

